## **EAST SEARCH**

		EAST SEARCH	12/15/05
#	Hits	Hits Search String Databases	Databases
S1	2	6,581,191.pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB
S2	7	6,618,839.pn.	US-PGPUB; USPAT, EPO; JPO, DERWENT; IBM_TDB
S3	473212	(integrated or digital) adj circuit\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S4	1329	((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
SS	7	((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
Se	48	((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S7	7	(((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S8	97	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S <sub>9</sub>	7	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S10	78	(((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S11	78	(((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S12	9	(((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S13	œ	(((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S14	თ	(((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S15	თ	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S16	9	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S17	42	((integrated or digital) adj circuit\$1) and (debug\$4 with (target near2 (environment	(US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S18	7	((integrated or digital) adj circuit\$1) and (debug\$4 with (target near2 environment)	, US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S19	7	((integrated or digital) adj circuit\$1) and (debug\$4 with (target near2 environment)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S20	=	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S21	0	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S22	7	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S23	7	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S24	8	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S25	22	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S26	113	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S27	4	circuit\$1) and ((HDL near2 (description or describe\$1)) same debug\$4)) and (state	I US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S28	0	5,937,190.pn. and (control near2 signal)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S29	9	and ((HDL near2 (description or describe\$1)) same debug\$4)) and (signal with (H	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S30	17	(((integrated or digital) adj circuit\$1) and ((HDL near2 (description or describe\$1))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S31	7	5,859,993.pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S32	7	6,625,787.pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S33	7	6,353,906.pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S34	2	6,006,022.pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
<b>S35</b>	7	6,618,854.pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S36	7	6,272,451.pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S37	7	5,937,190.pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
838	1329	((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
839	28	(((integrated or digital) adj circuit\$1) and (HDL near2 (description or describe\$1)))	: US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S40	630455	((integrated or digital) adj circuit\$1) or (electronic near2 system)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S41	486	S40 and (instrumentation near2 circuit\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S42	2	S40 and ((instrumentation near2 circuit\$2) with (debug\$3 or test\$3 or simulat\$3 or	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S43	58469	S40 and ((((integrated or digital) adj circuit\$1) or (electronic near2 system)) with fa	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S44	٤ إ	S41 and S43	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S45	102	S42 of S44	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
246	ກ	S45 and ("HUL description")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB

S47		S41 and ((instrumentation near2 circuit\$2) with configur\$3)	US-PGPUB: USPAT; EPO; JPO; DERWENT; IBM TDB
S48		S45 or S46 or S47	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S49		S40 and (embedded near2 test near2 circuitry)	US-PGPUB, USPAT, EPO, JPO, DERWENT, IBM_TDB
S50		S40 and ((test near2 circuitry) with configur\$5)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
S51		S49 and S50	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB
S52	0	S40 and ((embedded near2 test near2 circuitry) same "HDL description")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
Ξ	733888	((integrated or digital) adj circuit\$1) or (electronic near2 system) US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB
7		L1 and (instrumentation near2 circuit\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB
<b>1</b> 3		L1 and ((instrumentation near2 circuit\$2) with (debug\$3 or test\$3 or simulat\$3 or	US-PGPUB; USPAT, EPO; JPO; DERWENT, IBM_TDB
7		L1 and ((((integrated or digital) adj circuit\$1) or (electronic near2 system)) with fab	IUS-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
LS		L2 and L4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
Pe		L3 or L5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
77		L6 and ("HDL description")	US-PGPUB; USPAT; EPO, JPO; DERWENT; IBM_TDB
F8		L2 and ((instrumentation near2 circuit\$2) with configur\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
67		L6 or L7 or L8	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
710		9 and (instrumentation.CLM.)	US-PGPUB, USPAT, EPO, JPO, DERWENT, IBM_TDB
L12		10 and ("HDL description". CLM.)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
L13		11 and 12	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
11		10 and (configuration.CLM.)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
L14		10 or 11 or 12 or 13	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
09/724585		John Beardslee et al.	

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Abstract																							
Current OR	20040916 341/143	20040812 29/428	20040722 257/537	20040520 29/593	20040513 702/23	20040422 700/79	20040212 361/767	20040205 716/4	20040205 361/763	20031016 29/857	20030925 716/4	20030911 205/122	20030821 324/762	20030717 438/18	20030717 324/754	20030710 716/4	20030515 324/754	20030410 703/16	20030220 607/9	20021226 702/117	20021226 257/700	20021219 361/306.1	20020926 324/754
Issue Date		8	20	20	20	20		20		20	20	20	20	20	20	20	8		20	20			20
et S48: st Title	Ο.	Membrane probing system	Increasing an electrical resistance of a resistor by oxidation or nitridization	Membrane probing system	Analyte detection system with software download capabilities	Plant protective instrumentation equipment	Manufacturing methods for an electronic assembly with vertically connected capaci	Hardware-based HDL code coverage and design analysis	Electronic package with back side, cavity mounted capacitors and method of fabric	Method for constructing a membrane probe using a depression	Hardware debugging in a hardware description language	Self-aligned coaxial via capacitors	Method for forming cantilever beam probe card and probe card formed	Micro probing tip made by micro machine method	Membrane probing system	Method and user interface for debugging an electronic system	Membrane probing system	Method and system for debugging an electronic system using instrumentation circu	MRI-compatible implantable device	Method for testing integrated circuits	Electronic assembly with vertically connected capacitors and manufacturing methor	Electronic assembly with laterally connected capacitors and manufacturing method	Membrane probing system with local contact scrub
Results of search set S48: Document Kind Codes Title	US 20040178938 A1	US 20040154155 A1	US 20040140529 A1	US 20040093716 A1	US 20040093167 A1	US 20040078101 A1	US 20040027813 A1	US 20040025122 A1	US 20040022038 A1	US 20030192183 A1	US 20030182642 A1	US 20030168342 A1	US 20030155940 A1	US 20030134441 A1	US 20030132767 A1	US 20030131325 A1	US 20030090278 A1	US 20030069724 A1	US 20030036776 A1	US 20020198674 A1	US 20020195700 A1	US 20020191368 A1	US 20020135388 A1

20020926 205/125	20020326 1747260	20020919 439/862				20011018 324/758			20010726 29/593	20040928 438/14	20040629 702/117	20040504 257/537		20040323 29/593		20031111 600/300		20030923 702/117	20030909 716/4	20030708 257/781			20030520 205/122		20030311 361/301.4	20021119 361/308.1	20020917 361/303	20020910 29/25.42		20020618 361/763	20011023 324/754	20010/10 29/8/4	20010320 3211303		20001107 607/28	20001017 607/28	20000919 356/338	20000613 250/207	20000328 362/259	20000222 438/396			19991026 359/619		19990914 702/31	19990810 372/38.02	19990810 417/392	19990622 324/754
SELF-ALIGNED COAXIAL VIA CAPACITORS Hubrid canadiar circuit and exetom			_	Capacitor with extended surface lands and method of fabrication therefor	_	_	_			Micro probing tip made by micro machine method	Method and apparatus for testing integrated circuits using a synchronization signal	Increasing an electrical resistance of a resistor by oxidation or nitridization	Electronic assembly and system with vertically connected capacitors	Neurou for probing an electrical device naving a layer of oxide mereon Discrete device coatst and mathod of the incition thereon	Method for forming cantilever beam probe card and probe card formed	Glucose monitoring instrument having network connectivity	Electronic assembly with laterally connected capacitors and manufacturing method	Mixed signal device under test board interface	Method and system for providing an electronic system design with enhanced debut	Device for bump probing and method of fabrication	Hardware debugging in a hardware description language	Method for constructing a membrane probe using a depression	Self-aligned coaxial via capacitors	Instrumentation amplifier and method for obtaining high common mode rejection	Multiple tier array capacitor	Capacitor with extended surface lands and method of fabrication therefor	Capacitor with defect isolation and bypass	Hybrid capacitor and method of fabrication therefor	Membrane probing system with local contact scrub	Electronic package having embedded capacitors and method of fabrication therefor	Membrane probing system with local contact scrub	Membrane proping system Signal amplifutor circuit	Organization and system for selectively disabling simulation model instrumentation	Microprocessor capture detection circuit and method	Capture detection circuit for pulses and physiologic signals	Microprocessor capture detection circuit and method	Apparatus for measuring particle fallout on a surface using a telltale plate	Non-contact method and apparatus to obtain a timing signal from internal integrater	Illuminator optical assembly for an analytical instrument and methods of alignment:	Method of forming a decoupling capacitor	Reliable. modular, production quality narrow-band KRF excimer laser	Decoupling capacitor in an integrated circuit	Method and apparatus for an optical illuminator assembly and its alignment	Microprocessor capture detection circuit and method	Autonomous node for a test instrument system having a distributed logic nodal arch	Methods and apparatus for driving a laser diode	Reagent pump assembly	Membrane probing system with local contact scrub
US 20020134685 A1	115 20020134561 A1	US 20020113651 A1	US 20020085334 A1	US 20020075630 A1	US 20020068858 A1	US 20010030549 A1	US 20010010468 A1	US 20010009785 A1	US 20010009061 A1	US 6797528 B2	US 6/5/632 B2	US 6730984 B1	US 67 1386U BZ	US 6672012 B2	US 6651325 B2	US 6645142 B2	US 6636416 B2	US 6625557 B1	US 6618839 B1	US 6590294 B1	US 6581191 B1	US 6578264 B1	US 6565/30 B2	US 6538503 B2	US 6532143 B2	US 6483692 BZ	US 6452776 B1	US 6446317 B1	US 6437584 B1	US 640/929 B1	US 6307387 B1	US 620602 B1	US 6195629 B1	US 6163724 A	US 6144881 A	US 6134473 A	US 6122053 A	US 6075234 A	US 6042249 A	US 6027980 A	US 5991324 A	US 5973910 A	US 5973842 A	US 5954756 A	US 5953681 A	US 5936986 A	US 3934863 A	US 5914613 A

	19980428 359/818 19980428 359/818 19971223 324/628 19971225 73/863.73 19971118 324/627 19970715 708/801 19961217 33/1/11 19961210 36/1/313 19961202 33/1/11 19961202 33/1/11 19950509 324/762 19950516 324/762 19950516 324/762 19950617 36/1/2 19970623 324/1724 19890815 600/505 19800815 600/505 19800815 500/306 19870623 323/317 19830823 703/13	19811215 84/611 19810804 341/118 19810414 324/72.5 19801104 330/258 19790123 84/635 19720404 439/65 19720404 439/65 19711221 324/73.1 20031010 20030909 20030410 55 20030410 19950419
Heated reaction chamber in a unified fluid circuit of a hematology diagnostic instrun Apparatus and methods for transmitting electrical signals indicative of optical intera Microprocessor capture detection circuit and method Method and apparatus for detection scattered light in an analytical instrument Microprocessor capture detection circuit and method Reference laser beam sampling apparatus Generic interface test adapter Unified fluid circuit assembly for a clinical hematology instrument	Analytical instrument having a control area network and distributed logic nodes whethods and apparatus for an optical illuminator assembly and its alignment. Apparatus for filtering a laser beam in an analytical instrument. Probe for sensing moculated signals and method of using same Apparatus and methods for selecting a variable number of test sample aliquots to neuron. It is a controlled voltage for testing circuits for electromagnetic su Silicon neuron. Low power RC oscillator using a low voltage bias circuit. Capacitor fabricated on a substrate containing electronic circuitry Micropower RC oscillator having hysteresis produced by switching current sources. Apparatus for low cost electromagnetic field susceptibility testing. Capacitor fabricated on a substrate containing electronic circuitry Methods of fabricating integrated, aligned tunneling tip pairs. Probe assembly for testing integrated circuits. Apparatus and method for low cost electromagnetic field susceptibility testing. Timing generation in an automatic electrical test system. Methods of fabricating integrated, aligned tunneling tip pairs. Hinged interlocking receiver for mainframe card cage. Apparatus and method for testing printed circuit boards and their components. Catheter identifier and method of testing printed circuit boards and their components. Woltage-to-current converter. Method of making zero temperature coefficient of resistance resistors. Magnetic heading simulator.	Modular drum generator  Modular drum generator  Analog to digital encoding system with an encoder structure incorporating instrume System for servicing process instrumentation Instrumentation amplifier with extended common mode range Automatic mythm generator TESTING APPARATUS FOR ELASTOMERS COORDINATE CONVERSION FOR THE TESTING OF PRINTED CIRCUIT BOAF DIGITAL MOS FET CHARACTERISTIC TESTER PRERECORDED ELECTRONIC TAPE CONTROLLED CIRCUIT TESTING SYST PLANT PROTECTION INSTRUMENTATION DEVICE Fabricated integrated circuit debugging method 6.9. for application specific integrat Fabricated integrated circuits debugging method for electronic system designs, inve Computer system debugging method involves translating debug data received from Integrated circuit test instrumentation triggering method involves applying trigger si; Mixed analogue and digital integrated circuit for physiological instrumentation - has Interference pulse detection circuit for instrumentation testing - has input or-gate fo
US 5908599 A US 5883378 A US 5873698 A US 5872657 A US 5871512 A US 5844685 A US 5793218 A US 5783218 A	US 5772903 A US 5772903 A US 577308 A US 579667 A US 5691486 A US 5691486 A US 5691486 A US 5681765 A US 5683739 A US 5582765 A US 5582775 A US 5570067 A US 5472900 A US 547250 A US 57550 A US 4856500 A US 4856570 A US 4856570 A US 4856570 A US 4856570 A	US 4305319 A US 4282515 A US 4262248 A US 4232271 A US 4135423 A US 3818751 A US 3836450 A US 3628695 A US 3628695 A US 2003287587 A US 6618839 B US 200300131325 A US 20030069724 A US 6075234 A

Interference checking

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09/724585 L L# L1 L2 L3 L4 L6 L7 L10 L11 L13 L13 L14 L13 L14 L15 L16 L16 L17 L17 L17 L17 L17 L17 L17 L17 L17 L17	Hits 733888 557 757 757 103 103 114 116 116 117 116 117 117 117 114 117 114 114 114 114 114	EAST SEARCH  Search String  (Integrated or digital) adj circuit\$1) or (electronic near2 system)  L1 and (instrumentation near2 circuit\$2) with (debug\$3 or simulat\$3 or eu US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB L1 and (instrumentation near2 circuit\$2) with (debug\$3 or simulat\$3 or eu US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB L2 and (instrumentation near2 circuit\$2) with (debug\$3 or simulat\$3 or eu US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB L3 or L5 and (instrumentation near2 circuit\$2) with configur\$3) or lest\$3 or simulat\$3 or eu US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB US-PGPUB; USPAT; EPO; DERWENT; IBM_TDB US-PGPUB; USPAT; EPO; DERWENT; IBM_TDB US-PGPUB; USPAT;	Databases US-PGPUB, USPAT; EPO; JPO; DERWENT; IBM_TDB US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB US-PGPUB
17 17 17 17 17 17	°, ≈ ⊙ – ≈	13 and 10 (instrumentation.CLM.) 17 and (instrumentation".CLM.) 17 and (configuration.CLM.) 18 or 19 or 21	US-PGPUB US-PGPUB US-PGPUB US-PGPUB US-PGPUB

Results of search set S48: Document Kind Codes Title	tt S48: s Title	Issue Date Current OR Abstract	īag
US 20040178938 A1	US 20040178938 A1 Circuit for direct digital delta-sigma conversion of variable electrical capacitance	20040916 341/143	
US 20040154155 A1	US 20040154155 A1 Membrane probing system	20040812 29/428	
US 20040140529 A1	US 20040140529 A1 Increasing an electrical resistance of a resistor by oxidation or nitridization	20040722 257/537	
US 20040093716 A1	US 20040093716 A1 Membrane probing system	20040520 29/593	
US 20040093167 A1	Analyte detection system with software download capabilities	20040513 702/23	
US 20040078101 A1	US 20040078101 A1 Plant protective instrumentation equipment	20040422 700/79	
US 20040027813 A1	US 20040027813 A1 Manufacturing methods for an electronic assembly with vertically connected capac	20040212 361/767	
US 20040025122 A1	Hardware-based HDL code coverage and design analysis	20040205 716/4	
US 20040022038 A1	US 20040022038 A1 Electronic package with back side, cavity mounted capacitors and method of fabric	20040205 361/763	
US 20030192183 A1	US 20030192183 A1 Method for constructing a membrane probe using a depression	20031016 29/857	
US 20030182642 A1	US 20030182642 A1 Hardware debugging in a hardware description language	20030925 716/4	
US 20030168342 A1	US 20030168342 A1 Self-aligned coaxial via capacitors	20030911 205/122	
US 20030155940 A1	US 20030155940 A1 Method for forming cantilever beam probe card and probe card formed	20030821 324/762	

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20030717 438/18 20030717 324/754 20030710 716/4 20030515 324/754 20030210 703/16 20030220 607/9	20021226 2577700 20021219 361/306.1 20020926 324/754 20020926 205/125 20020926 174/260 20020919 439/862 20020873 330/258	20020/04 361/301.4 20020620 361/308.1 20020606 600/316 2001010 324/758 20010802 324/715 20010726 29/593 20040928 438/14		20031021 361/306.1 20030923 702/117 20030909 716/4 20030708 257/781 20030617 716/4 20030520 205/122 20030325 330/9 2003031 361/301.4	20021119 361/308.1 20020917 361/303 20020910 29/25.42 20020820 324/754 2001020 324/754 20010710 29/874 20010320 327/309 20010227 703/17 20001219 607/28
Micro probing tip made by micro machine method Membrane probing system Method and user interface for debugging an electronic system Membrane probing system Method and system for debugging an electronic system using instrumentation circu MRI-compatible implantable device Method for testing integrated circuits	Electronic assembly with vertically connected capacitors and manufacturing methor Electronic assembly with laterally connected capacitors and manufacturing method Membrane probing system with local contact scrub SELF-ALIGNED COAXIAL VIA CAPACITORS Hybrid capacitor, circuit, and system Discrete device socket and method of fabrication therefor Instrumentation amplifier	worther ter anay capacitor and methods or labrication ineretor. Capacitor with extended surface lands and method of fabrication therefor. Glucose monitoring instrument having network connectivity. Membrane probing system. Membrane probing system. Membrane probing system. Membrane probing system. Micro probing tip made by micro machine method. Method and apparatus for testing integrated circuits using a synchronization signal.	Increasing an electrical resistance of a resistor by oxidation criticalization linearing an electrical resistance of a resistor by oxidation or nitridization electronic assembly and system with vertically connected capacitors. Method for probing an electrical device having a layer of oxide thereon Discrete device socket and method of fabrication therefor Method for forming cantilever beam probe card and probe card formed Glucose monitoring instrument having network connectivity	Electronic assembly with laterally connected capacitors and manufacturing method Mixed signal device under test board interface Method and system for providing an electronic system design with enhanced debu. Device for bump probing and method of fabrication Hardware debugging in a hardware description language Method for constructing a membrane probe using a depression Self-aligned coaxial via capacitors Instrumentation amplifier and method for obtaining high common mode rejection Multiple tier array capacitor	Capacitor with extended surface lands and method of fabrication therefor Capacitor with defect isolation and bypass Hybrid capacitor and method of fabrication therefor Membrane probing system with local contact scrub Electronic package having embedded capacitors and method of fabrication therefor Membrane probing system with local contact scrub Membrane probing system Signal amplifying circuit Method and system for selectively disabling simulation model instrumentation Microprocessor capture detection circuit and method Capture detection circuit for pulses and physiologic signals
US 20030134441 A1 US 20030132767 A1 US 20030131325 A1 US 20030090278 A1 US 20030069724 A1 US 20030036776 A1 US 20020198674 A1	US 20020195700 A1 US 20020191368 A1 US 20020135388 A1 US 20020134685 A1 US 20020134581 A1 US 20020132533 A1 US 20020113651 A1 US 20020113651 A1	US 20020075630 A1 US 20020068858 A1 US 20010030549 A1 US 20010010468 A1 US 200100099755 A1 US 20010009961 A1 US 6797528 B2 US 6757632 B2	US 673094 B1 US 6730984 B1 US 6730986 B2 US 6672912 B2 US 6651325 B2 US 6645142 B2	US 6634416 B2 US 662557 B1 US 662839 B1 US 6590294 B1 US 6581191 B1 US 6578264 B1 US 655730 B2 US 6553603 B2 US 6538603 B2	US 648392 B2 US 6452776 B1 US 646317 B1 US 6437584 B1 US 6407929 B1 US 6307387 B1 US 6204715 B1 US 6195629 B1 US 6195629 B1 US 6195629 B1

US 6134473 A	Microprocessor capture detection circuit and method	20001017 607/28
US 6122053 A	Apparatus for measuring particle fallout on a surface using a telltale plate	20000919 356/338
US 6075234 A	Non-contact method and apparatus to obtain a timing signal from internal integrate	20000613 250/207
US 6042249 A	Illuminator optical assembly for an analytical instrument and methods of alignment	20000328 362/259
US 6027980 A	Method of forming a decoupling capacitor	20000222 438/396
US 5991324 A	Reliable. modular, production quality narrow-band KRF excimer laser	19991123 372/57
US 5973910 A	Decoupling capacitor in an integrated circuit	19991026 361/313
US 5973842 A	Method and apparatus for an optical illuminator assembly and its alignment	19991026 359/619
US 5954756 A	Microprocessor capture detection circuit and method	19990921 607/28
US 5953681 A	Autonomous node for a test instrument system having a distributed logic nodal arc	19990914 702/31
US 5936986 A	Methods and apparatus for driving a laser diode	19990810 372/38.02
US 5934885 A	Reagent pump assembly	19990810 417/392
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US 5908599 A	Heated reaction chamber in a unified fluid circuit of a hematology diagnostic instrui	19990601 422/50
US 5883378 A	Apparatus and methods for transmitting electrical signals indicative of optical intera	19990316 250/214A
US 5873898 A	Microprocessor capture detection circuit and method	19990223 607/28
US 5872627 A	Method and apparatus for detecting scattered light in an analytical instrument	19990216 356/338
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US 5844685 A	Reference laser beam sampling apparatus	
US 5793218 A	Generic interface test adapter	19980811 324/754
US 5788927 A	Unified fluid circuit assembly for a clinical hematology instrument	19980804 422/63
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US 5719667 A	Apparatus for filtering a laser beam in an analytical instrument	19980217 356/73
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US 5691486 A	Apparatus and methods for selecting a variable number of test sample aliquots to t	19971125 73/863.73
US 5689192 A	Method for simulating a controlled voltage for testing circuits for electromagnetic su	19971118 324/627
US 5648926 A	Silicon neuron	19970715 708/801
US 5585765 A	Low power RC oscillator using a low voltage bias circuit	19961217 331/111
US 5583739 A	Capacitor fabricated on a substrate containing electronic circuitry	19961210 361/313
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US 5472900 A	Capacitor fabricated on a substrate containing electronic circuitry	19951205 438/396
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US 5416429 A	Probe assembly for testing integrated circuits	19950516 324/762
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US 5103378 A	Hinged interlocking receiver for mainframe card cage	
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US 4579600 A	Method of making zero temperature coefficient of resistance resistors	19860401 438/385
US 4400789 A	Magnetic heading simulator	19830823 703/13
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Results of search set L14 Document Kind Codes Title Dos 20050193280 A1 Des US 20050193280 A1 Des US 20050193280 A1 Des US 20050105281 A1 Har US 20050105281 A1 Har US 20050010880 A1 Met US 20030182624 A1 Har US 20030131325 A1 Met US 20030131225 A1 Har US 20030131225 A1 Har US 20030131225 A1 Met US 20030131225 A1 Met US 6031572 B1 Des US 6994577 B2 Har US 6994577 B2 Har US 6994577 B2 Har US 6994577 B2 Har US 6994577 B2 Cattle US 658503 B2 Met US 6994577 B2 Cattle US 658503 B2 Met US 658503 B3 Met US 658503 B4 Met US 658503 B4 Met US 658503 B4 Met US 699524 A Non US 6995327 A Non US 6995227 A Inst US 6995227 A Inst US 6995227 A Inst	instrumentation circuitry hod and system for selective compilation of instrumentation entities into a simulation and system for selective compilation of instrumentation entities into a simulation and system for selective compilation language CCTRONIC MODULE WITH REMOVABLE CIRCUITRY AND METHOD THERE hod and user interface for debugging an electronic system typrotective instrumentation equipment dware-based HDL code coverage and design analysis dware debugging in a hardware description language hod and user interface for debugging an electronic system rumentation amplifier ign instrumentation circuitry dware debugging in a hardware description language hod and user interface for debugging an electronic system hod and user interface for debugging an electronic system hod and user interface for debugging an electronic system hod and user interface for debugging in a hardware description language hod and system for providing an electronic system hod and system for providing an electronic system hod and system for providing an electronic system hod and system for selectively disabling simulation model instrumentation hod and system for selectively disabling simulation model instrumentation recontact method and apparatus to obtain a timing signal from internal integrate able. modular, production quality narrow-band KRF excimer laser heter identifier and method rumentation amplifier with extended common mode range	Issue Date  20050901 714/47  20050707 703/22  20050609 716/5  20050613 716/4  20040422 700/79  20040422 700/79  2004022 716/4  20030710 716/4  20030710 716/4  20030410 703/16  20050812 716/4  20050812 716/4  20050817 716/4  20050817 716/4  2003090 716/4  2003090 716/4  2003091 716/4  2003091 716/4  2003091 716/4  2003091 716/4  2003091 716/4  200301 716/4